

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi OKUBO et al.

Application No.: 10/551,136

Filed: January 5, 2006

Docket No.: 125493

For: MASK BLANK, MANUFACTURING METHOD OF MASK BLANK,  
MANUFACTURING METHOD OF TRANSFER MASK AND MANUFACTURING  
METHOD OF SEMICONDUCTOR DEVICE

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Specification;**

**Remarks.**